



-JPW

Docket No.: 050432-0395

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of	:	Customer Number: 20277
Akif SULTAN, et al.	:	Confirmation Number: 6644
Application No.: 10/759,171	:	Group Art Unit: 2812
Filed: January 20, 2004	:	Examiner: S. Isaac

For: METHOD OF FORMING MINIATURIZED POLYCRYSTALLINE SILICON GATE  
ELECTRODES USING SELECTIVE OXIDATION

**AMENDMENT**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The following Amendment and Remarks are submitted in response to the Office Action  
dated February 25, 2005.